

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/046,330
Filing Date October 25, 2001
Inventor Wuwen Yi et al.
Assignee Honeywell International Inc.
Group Art Unit 2818
Examiner P. T. Dang
Attorney's Docket No. JM32810-CIP (HO57-232)
Title: Physical Vapor Deposition Targets

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference -- See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the references listed on the attached Form PTO-1449. No admission is made regarding whether the submitted references are prior art. The Examiner is requested to make this citation of official record in this application.

The attached foreign patents were cited in the corresponding European Patent application on July 15, 2003, and are now being submitted in this Supplemental Information Disclosure Statement. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.


Citation of these references is respectfully requested.

Respectfully submitted,

Dated: _____

9/4/03

Attorney: _____



David G. Latwesen, Ph.D.
Reg. No. 38,533

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. JM32810-CIF	SERIAL NO 10046330		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Wuwei Yi et al.			
					FILING DATE October 25, 2001	PRIORITY GROUP 2818		
U.S. PATENT DOCUMENTS								
*Examiner Initial	Class	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
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	AH							
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	AK							
	AL							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM	01135969	30-05-1989	Japan (abstract)			x	
	AN	01247619	04-10-1989	Japan (abstract)			x	
	AO							
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Relevant Pages, Etc.)								
	AR							
	AS							
EXAMINER					DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								